

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Mu-Tsang Lin

Group Art Unit: 176

Serial No.: 09/ 903,130

Examiner: Hassanzadeh, Par

Filed:

ADEM

July 11, 2001

In Response to Office Action

Dated: April 29, 2003

For:

Direct Detection of Dielectric Etch System Magnet

Driver and Coil Malfunctions

Attorney Docket No.: 67,200-464

Certificate of Mailing

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first-class mail in an envelope addressed to: dommissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Alexandria, VA 22313-1450

Date: May 7, 2003

RESPONSE TO OFFICE ACTION

Commissioner for Patents

Dear Sir:

P.O. Box 1450

In response to an Office Action mailed April 29, 2003 of a restriction requirement imposed by the Examiner, the Applicants hereby elect with traverse the prosecution of Group I, apparatus claims, (claims 1-6).

Respectfully submitted,

ung & **A**ssociates

Randy W. Tung

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